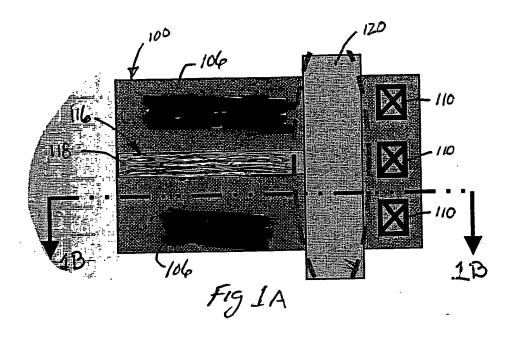
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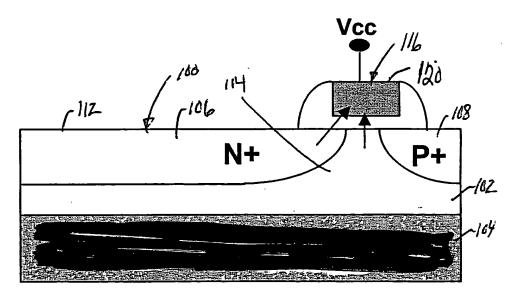
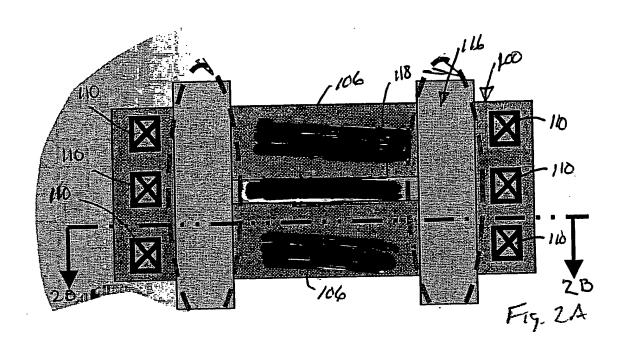
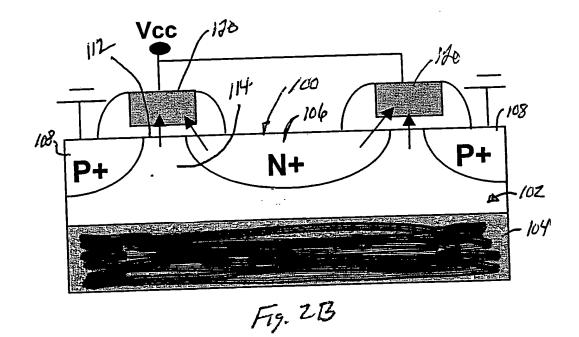


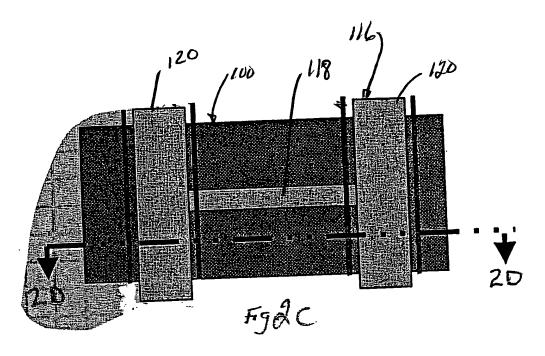
Fig. 1B

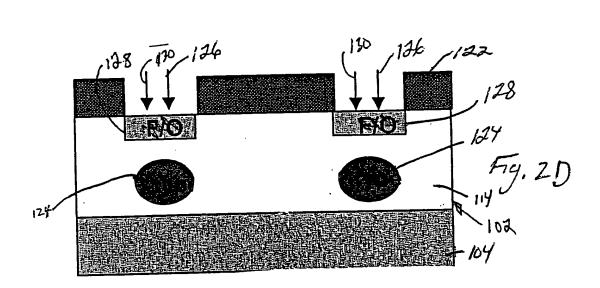
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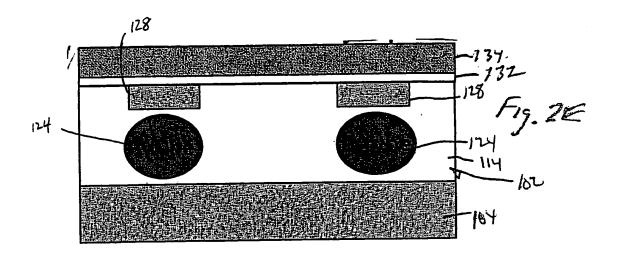


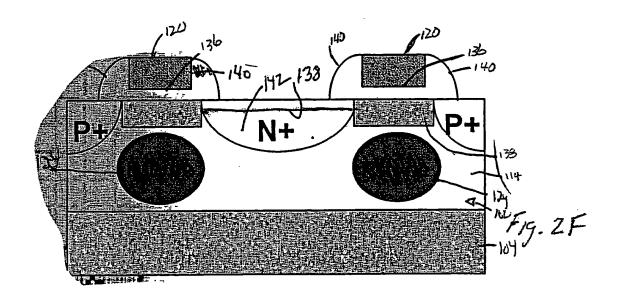
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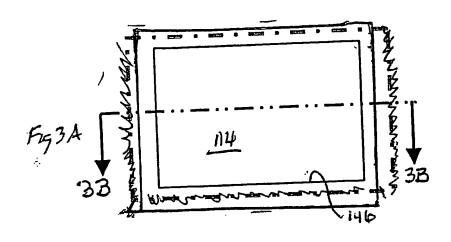


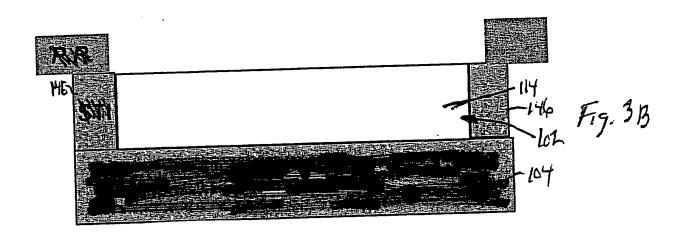
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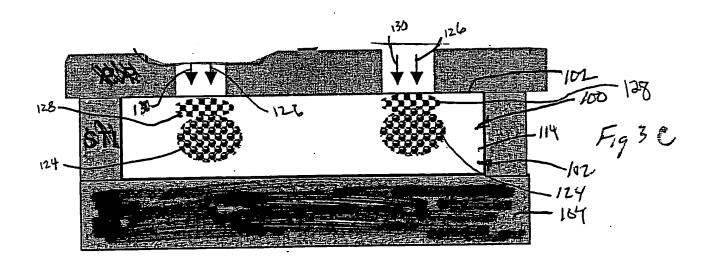




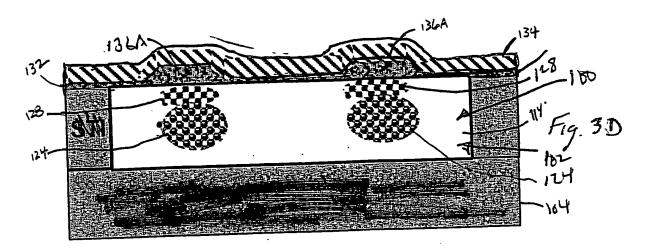
Docket No. N1085-00168
Inventors: Shui-Ming Cheng et al.
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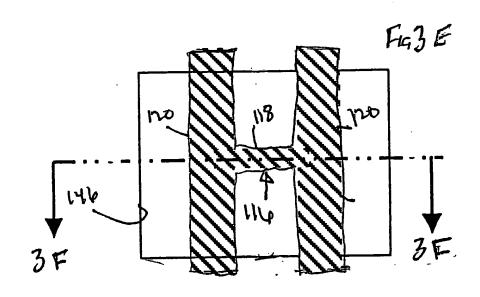


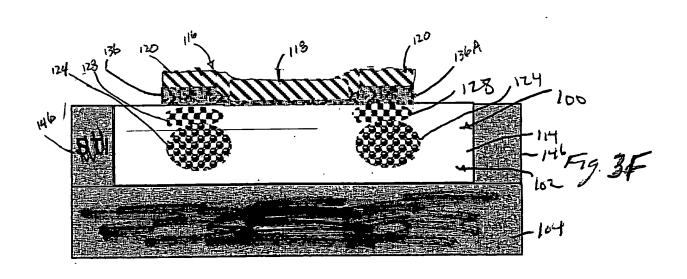




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